

An Ultra Low-Loss Silicon-Micromachined Waveguide Filter for D-Band Telecommunication Applications

James Champion*, Oleksandr Glubokov*, Adrián Gomez*, Aleksandr Krivovitca*,
Umer Shah*, Lars Bolander †, Yinggang Li† and Joachim Oberhammer*

* Dept. of Micro and Nanosystems, KTH Royal Institute of Technology, Stockholm, Sweden.

jcampion@kth.se

†Ericsson Research, SE-417 56, Göteborg, Sweden

Abstract—A very low-loss micromachined waveguide bandpass filter for use in D-band (110–170 GHz) telecommunication applications is presented. The 134–146 GHz filter is implemented in a silicon micromachined technology which utilises a double H-plane split, resulting in significantly lower insertion loss than conventional micromachined waveguide devices. Custom split-blocks are designed and implemented to interface with the micromachined component. Compact micromachined E-plane bends connect the split-blocks and DUT. The measured insertion loss per unit length of the waveguide technology (0.008–0.016 dB/mm) is the lowest reported to date for any micromachined waveguide at D-band. The fabricated 6-pole filter, with a bandwidth of 11.8 GHz (8.4%), has a minimum insertion loss of 0.41 dB, averaging 0.5 dB across its 1 dB bandwidth, making it the lowest-loss D-band filter reported to date in any technology. Its return loss is better than 20 dB across 85% of the same bandwidth. The unloaded quality factor of a single cavity resonator implemented in this technology is estimated to be 1600.

Index Terms—D-band, bandpass filter, micromachined waveguide, waveguide filter, wireless link, telecommunication

I. INTRODUCTION

The continued growth of wireless data traffic, which has increased by a factor of 18 over the past 5 years [1], has pushed current wireless networks to the limit of their capacity. The increase in capacity required for future wireless communications can only be supported via an increase in system bandwidth. This factor, coupled with the expense and difficulty of constructing optical-fiber based networks, has created interest in wireless networks operating at frequencies above 100 GHz, where large swathes of continuous bandwidth are available. Such systems are enabled by developments in semiconductor design and processing technology. Modern low-cost, commercial semiconductor technologies, such as silicon germanium BiCMOS, enable the large-scale implementation of transceiver circuits above 100 GHz. The band of frequencies between 110–170 GHz, known as the D-band, offers relatively low atmospheric attenuation (< 1 dB/km, [2]), making it attractive for use in short/medium distance applications such as wireless backhaul. Theoretical link budget calculations [2] have shown that wireless links operating at D-band can support data rates of up to 10 Gbps/GHz. Practical system demonstrations report data rates of up to 48 Gbps [3], confirming the potential of wireless links operating in this band.

A major limiting factor in the design of such systems is the low quality factor (Q) of transmission lines implemented in

these technologies, which prevents on-chip integration of low-loss passive components. High- Q bandpass filters are required for channel selection in practical wireless links. As a result, all necessary filtering is typically performed off-chip in a separate transmission medium. In [4], channel selection is performed using a waveguide bandpass filter, implemented in a CNC milled metallic split-block technology. This 7-pole filter achieved an insertion loss of between 1–2.5 dB with a bandwidth of 11.8 GHz (8.4%) centred at 139 GHz [5]. Metallic split-block components are expensive, bulky and offer limited tolerances and feature sizes.

In this work, we report on the development of a silicon-micromachined waveguide bandpass filter for use in a D-band telecommunication system. Micromachining (MEMS) offers many benefits for the creation of high- Q , low-cost waveguide components. It allows for the use of complex geometries with small, accurate features and reduces fabrication costs by taking advantage of batch processing techniques. RF-MEMS devices enable novel reconfigurable circuitry which cannot be implemented in other technologies [6]. Micromachined D-band filters by Zhao *et al.* [7] demonstrate low insertion loss (0.45 dB) but were measured with an un-calibrated system, resulting in a large uncertainty in the reported values.

II. FILTER DESIGN

The proposed waveguide filter consists of 6 cavities, directly coupled via inductive irises [8]. The dimensions of the filter and its coupling co-efficients are outlined in Fig. 1a. The filter was designed for a centre frequency of 144.75 GHz, which has been allocated for use in fixed wireless links, with a 3 dB bandwidth of 7.5 GHz (5.2%). The simulated insertion loss of the filter is 0.26–0.8 dB, while the return loss is greater than 23 dB in the passband (Fig. 1b). A conductivity of 2.1×10^7 S/m was used during simulation to account for surface roughness effects.

Due to the design of the radio system, the proposed waveguide filter must be implemented such that its ports lie in the same plane. This required the design of custom metal split-blocks for test and verification purposes. The split-blocks are made of high-conductivity aluminium, realised in an E-plane split design using CNC milling. The finalised micromachined filters are inserted between a pair of split-blocks, which interface with standard WR-6 waveguides (Fig. 2a). Micromachined E-plane bends were used to transition between the split-blocks

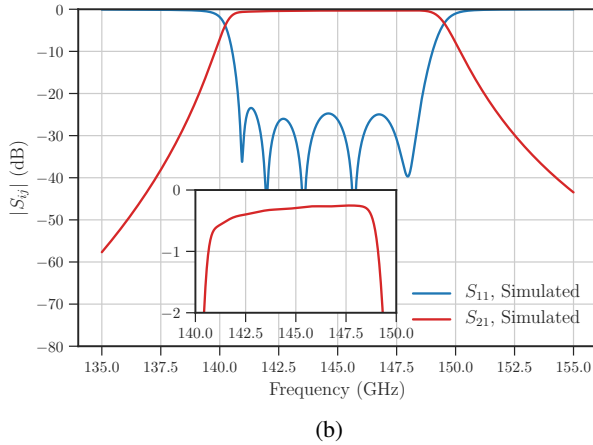
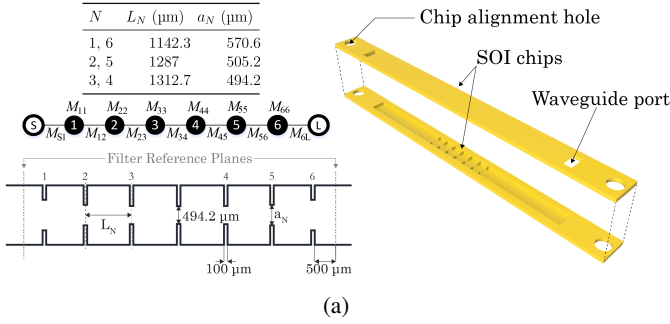


Fig. 1: (a) CAD model, cavity dimensions and coupling coefficients of the filter. $M_{S1} = 1.002$, $M_{12} = M_{56} = 0.843$, $M_{23} = M_{45} = 0.611$, $M_{34} = 0.583$, $M_{ii} = 0, i = 1$ to 6. (b) Simulated S -parameters of the filter, $\sigma = 2.1 \times 10^7 \text{ S m}^{-1}$.

and the DUT. The simulated S -parameters of a single bend are shown in Fig. 4. The simulated transition has an insertion loss below 0.1 dB and return loss greater than 16 dB across the D-band .

III. FABRICATION AND ASSEMBLY

The filter was implemented in a low-loss silicon micromachined waveguide technology which utilises a double H-plane split [9]. The insertion loss of this technology is significantly lower than other micromachined waveguide implementations. Two separate silicon-on-insulator (SOI) wafers are used to realise the complete waveguides, which are split along their H-plane. The height of each waveguide half is defined by the thickness of the SOI wafer’s handle layer, allowing for precise control of this parameter.

Fabrication is performed in a three mask process, where photolithography is used to pattern the silicon oxide hard masks. The features of the filter are patterned in the handle layer of a single wafer via deep reactive ion etching. Discrete waveguide pieces are created by etching through the device and buried oxide layers of the SOI. Sputter deposition is used to apply $1 \mu\text{m}$ of gold to the chips. The individual waveguide halves are then assembled prior to thermo-compression bonding at 250°C . Alignment between the waveguide halves is facilitated

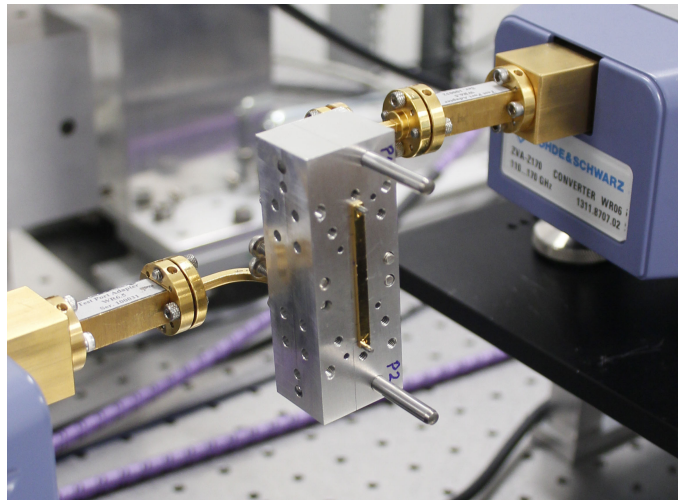
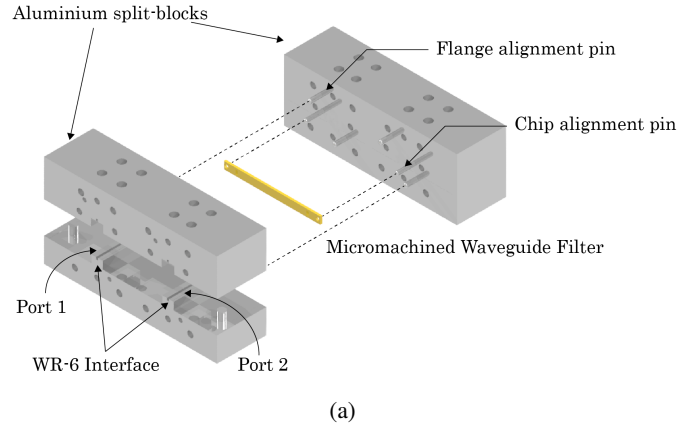


Fig. 2: (a) CAD model of the metallic split-block assembly. (b) A fabricated micromachined filter, mounted on the split-block assembly.

via self-alignment features patterned in the handle layer of each piece. The E-plane bends are realised by offsetting the etched area in the bottom chip, creating a waveguide step. An example of an assembled chip is shown in Fig. 2b.

IV. RF CHARACTERISATION

The RF performance of the filters was measured using Rohde & Schwarz ZVA-Z170 frequency extenders driven by a ZVA-24 VNA. The filter was mounted between the split-blocks detailed in Section II, which were connected to the frequency extenders via H-plane waveguide bends (Fig. 2b). Elliptical alignment holes [10] were implemented on all micromachined components to facilitate highly-accurate, repeatable alignment to the metallic split-blocks. Calibration was performed using an integrated LRL calibration kit, where the Thru was a non-zero-length straight waveguide and the Line was implemented as a $\lambda/4$ dog-leg. Following determination of the complex propagation constant of the waveguide the reference planes were shifted to the filter ports (Fig. 1a). This information

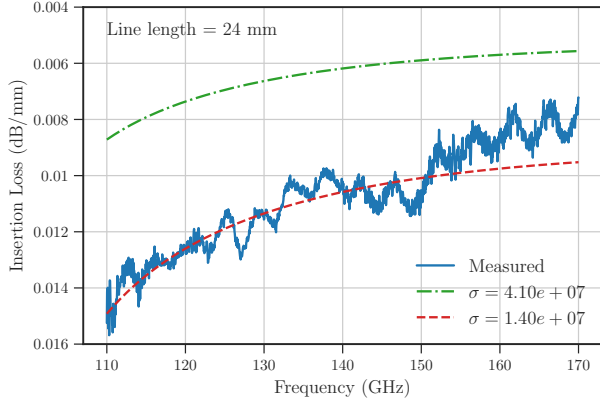


Fig. 3: Measured insertion loss per unit length of the micromachined waveguide, compared to theoretical values for conductivities $\sigma = 4.1 \times 10^7 \text{ S m}^{-1}$, $\sigma = 1.4 \times 10^7 \text{ S m}^{-1}$

also allows for the insertion loss of the waveguide technology to be determined. The resulting insertion loss per unit length is between 0.008–0.016 dB/mm across the D-band (Fig. 3). This corresponds to the theoretical conductive loss of an ideal rectangular waveguide with a conductivity of $\sigma = 1.4 \times 10^7 \text{ S m}^{-1}$ [11]. This effective conductivity value inherently includes the effects of the waveguide’s surface roughness. To the best of the authors’ knowledge, this represents the lowest-loss D-band silicon micromachined waveguide published to date. From the measured data, a single cavity resonator implemented in this technology is expected to have an unloaded Q factor of ~ 1600 .

The performance of the E-plane bend transition was verified via a two-tier, one-port calibration routine [12], calibrated firstly at the split-block faces and then at the reference plane inside the micromachined waveguide, where 5 offset-shorts were used as standards. Two-port S -parameters of the transition were extracted via de-embedding of the resulting error networks. Its insertion loss is below 0.5 dB and return loss greater than 15 dB across the entire band (Fig. 4).

The measured S -parameters of the bandpass filter are plotted in Fig. 5. The filter has a minimum insertion loss of 0.41 dB, averaging 0.5 dB across its 1 dB passband, which represents, to the best of the authors’ knowledge, the lowest insertion loss reported for a D-band filter of similar order and bandwidth in any technology to date. The passband return loss is greater than 20 dB across 85% of its 1 dB bandwidth. The fabricated filter exhibits a decrease in a centre frequency by 4.75 GHz. This was attributed to underetching of the waveguide sidewalls during fabrication, which increased the size of all 6 cavities and changed iris width/thickness, thereby detuning the filter.

V. CONCLUSION

A very low-loss micromachined waveguide filter for use in D-band telecommunications systems has been presented. The filter is implemented in an H-plane split technology, where each waveguide half comprises a single SOI wafer.

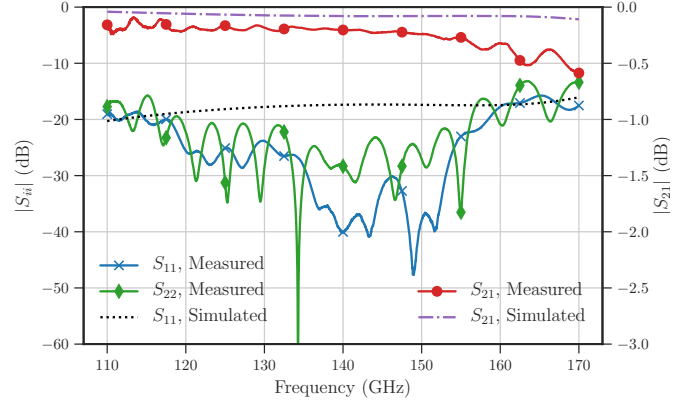


Fig. 4: Measured S -parameters of the micromachined E-plane bend transition.

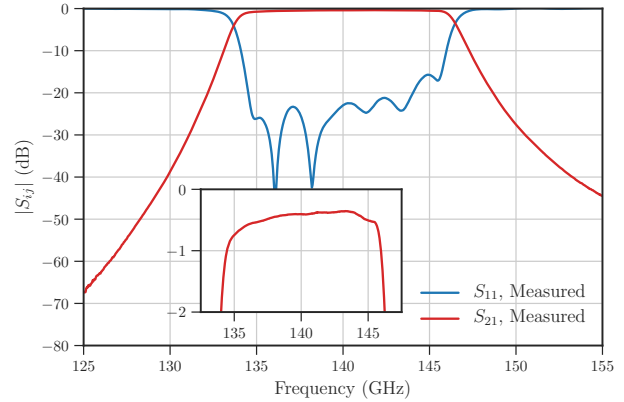


Fig. 5: Measured S -parameters of the micromachined waveguide filter.

Custom metallic split-blocks were designed and fabricated to connect the micromachined filter to standard WR-6 interfaces. The proposed filter achieves an insertion loss of 0.41 dB at 143 GHz, with an average of 0.5 dB across its passband. As such, the filter presented here has the lowest insertion loss of any D-band filter yet reported. This performance is due to the low insertion loss of the waveguide technology itself which, ranging between 0.008–0.016 dB/mm, is the lowest of any D-band waveguide reported to date. This performance makes micromachined waveguide components extremely promising for use in future telecommunication applications above 100 GHz.

ACKNOWLEDGEMENT

This work has received funding from the Swedish Foundation for Strategic Research Synergy Grant Electronics SE13-007, the European Research Council (ERC) under the European Union’s Horizon 2020 research and innovation programme (grant agreement No 616846) and the European Union’s Horizon 2020 research and innovation programme under grant agreement No 644039 (M3TERA). This research

made use of scikit-*rf*, an open-source Python package for RF and Microwave applications.

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